



10/15/02
RECEIVED
OCT 11 2002
TECHNICAL CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of:) Attorney Docket: 4425-154

)

LAI ET AL.

) Group Art Unit: 2823

)

Serial No.: 09/888,494

) Examiner: Long Pham

)

Filed: June 26, 2001

)

For: METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR
TYPE FIELD EFFECT TRANSISTOR

AMENDMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

This paper is in response to the Official Action dated July 9, 2002.
In that Official Action, Claims 1-18 are rejected under 35 U.S.C.
§103(a). Kindly amend the application in accordance with the following
particulars: